

F25B

(21) Int. Application Number: PCT/US96/19069	(51) International Patent Classification 6: F25B 7/00, F24D 11/00	(11) Int. Publication Number: WO 97/20178
(22) Int. Filing Date: 29 November 1996 (29.11.96)	(43) Int. Publication Date: 5 June 1997 (05.06.97)	
(30) Priority Data: 08/565,441 30 November 1995 US (30.11.95)		
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(81) Designated States: AL, AM, AT, AU, AZ, BB, BG, BR, BY, CA, CH, CN, CZ, DE, DK, EE, ES, FI, GB, GE, HU, IL, IS, JP, KE, KG, KP, KR, KZ, LK, LR, LS, LT, LU, LV, MD, MG, MK, MN, MW, MX, NO, NZ, PL, PT, RO, RU, SD, SE, SG, SI, SK, TJ, TM, TR, TT, UA, UG, UZ, VN, ARIPO patent (KE, LS, MW, SD, SZ, UG), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, CH, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, ML, MR, NE, SN, TD, TG).		
(54) Title: THERMAL STORAGE SYSTEM CONTROLLER AND METHOD		
(57) Abstract A thermal storage system (10) controller implements a near optimal control strategy for minimizing energy and demand costs. A system performance variable is determined and evaluated under a given set of environmental conditions for selecting one of a plurality of control strategies.		
Published With international search report.		

F25D

(21) Int. Application Number: PCT/JP96/03459	(51) International Patent Classification 6: F25D 1/02, 9/00, F24H 1/10	(11) Int. Publication Number: WO 97/20179
(22) Int. Filing Date: 26 November 1996 (26.11.96)	(43) Int. Publication Date: 5 June 1997 (05.06.97)	
(30) Priority Data: 7/312048 30 November 1995 JP (30.11.95) 8/28021 15 February 1996 JP (15.02.96) 8/180102 20 June 1996 JP (20.06.96) 8/180103 20 June 1996 JP (20.06.96)		
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(81) Designated States: CN, KR, SG, US, European patent (AT, BE, CH, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE).		
(54) Title: DISPERSION TYPE MULTI-TEMPERATURE CONTROL SYSTEM AND FLUID TEMPERATURE CONTROL DEVICE APPLICABLE TO THE SYSTEM		
(57) Abstract A fluid temperature control device is improved so as to be simple in construction, to provide a uniform fluid temperature and to heat even a fluid having a low light absorption rate. A fluid temperature control device includes a tubular inside container (20), a tubular outside container (22) surrounding the inside container (20), and a heating lamp (25) inserted into the inside container (20). Metallic fins (28a, 28b) are provided on inner and outer circumferential surfaces of the inside container (20) in such a manner as to erect from the surfaces, respectively. Working fluid is caused to flow in a flow path (21) between the inside container (20) and the heating lamp (25) and cooling water in a flow path (23) between the inside container (20) and the outside container (22). Infrared rays from the heating lamp (25) heat the working fluid and heat absorption into the cooling water cools the working fluid. This fluid temperature control device is used to control the temperatures of a plurality of process chambers equipped on, for instance, a reaction processing device. A plurality of the temperature control devices are disposed near the reaction processing device. Each temperature control device is exclusively assigned to each of a plurality of portions of the process chamber. Each temperature control device supplies the temperature-controlled working fluid to each portion of the process chamber.		
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